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Docket No.: HOK-0270
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tetsuji SHIBATA, et al.

Application No.: 10/529,861

Confirmation No.: 1482

Filed: March 31, 2005

Art Unit: 1763

For: PLASMA TREATMENT APPARATUS,
METHOD OF PRODUCING REACTION
VESSAL FOR PLASMA GENERATION, AND
PLASMA TREATMENT METHOD

Examiner: CROWELL, ANNA M

**RESPONSE TO RESTRICTION REQUIREMENT AND
PRELIMINARY AMENDMENT**

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction and Election of Species Requirement dated June 28, 2007, Applicants provisionally elect with traverse, Group I, claims 1-23 and 26-28, for examination on the merits. Applicants also elect with traverse, Species II, Figure 2b, corresponding to claims 1-3, 5, 7-9, 13-17, 19 and 26-27 for initial examination.

Please note that Applicants reserve the right to file divisional applications covering the subject matter of the non-elected claims. Applicants also reserve the right to rejoin any applicable non-elected claims.

In light of the restriction requirement, Applicants respectfully request that the above-identified application be amended as reflected in the listing of claims which begins on page 2 of this paper.